



Patent  
Attorney's Docket No. 015290-506

AF/1765  
#12  
10/9/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of ) **BOX AF**  
Ting CHIEN et al. )  
Application No.: 09/820,692 ) Group Art Unit: 1765  
Filed: March 30, 2001 ) Examiner: K.C. Chen  
For: PLASMA ETCHING OF ) Confirmation No. 5245  
DIELECTRIC LAYER WITH )  
SELECTIVITY TO STOP LAYER )

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TC 1700

NOTICE OF APPEAL

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

All finally rejected claims in the decision of the Primary Examiner dated August 7, 2002 are hereby appealed to the Board of Patent Appeals and Interferences.

- ☐ The Appeal fee was previously paid on \_\_\_\_\_ .  
Therefore, no Appeal fee is now required.  
☐ Small entity status is hereby claimed.  
☐ Enclosed is the Appeal fee of ☐ \$160.00 (2401) ☐ \$320.00 (1401).  
☒ Please charge the Appeal fee of ☐ \$160.00 (2401) ☒ \$320.00 (1401) to Deposit  
Account No. 02-4800.

The Commissioner is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in duplicate.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

By: \_\_\_\_\_

  
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Date: October 4, 2002

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